

Transfer Application of:

Examiner: *Lee, C.*

**Art Unit: 2627**

For: Document Surface Micro-Adjust Mechanism

COMMISSIONER FOR PATENTS  
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**AMENDMENT UNDER 37 CFR 1.114**

A Request for Continued Examination (RCE) under 37 CFR 1.114 is made regarding the above-referenced patent application. Assignee respectfully requests that the Examiner enter the following amendment, which includes an amendment to the claims, and consider the following remarks.

**Amendments begin on page 2.**

**Remarks** begin on page 6.